

IFW/1745

PATENT  
8007-1090



IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Shinichi MUSHA et al.

Conf. 7924

Application No. 10/529,487

Group 1745

Filed March 28, 2005

Examiner unknown

NEGATIVE ELECTRODE FOR NONAQUEOUS SECONDARY BATTERY, PROCESS  
OF PRODUCING THE NEGATIVE ELECTRODE AND NONAQUEOUS SECONDARY  
BATTERY

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In compliance with Rules 1.97 and 1.98, and in fulfillment of the duty of disclosure under Rule 1.56, the cited documents are made of record on the enclosed PTO Form-1449.

As the USPTO has waived the requirement under 37 CFR 1.98(a)(2)(i) for submitting a copy of each cited U.S. patent and patent publication for applications filed after June 30, 2003, copies of the cited U.S. references are not enclosed, as the present application is filed after June 30, 2003. Copies of the cited foreign patent documents and/or non-patent literature are enclosed.

A concise explanation of the relevance of these items is that these references were cited by the Japanese Patent Office in the corresponding Japanese Application.

Under the provisions of 37 CFR 1.97(e), the undersigned hereby certifies that each item of information contained in this Information Disclosure Statement was first

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cited in any communication from a foreign Patent Office in a counterpart foreign application not more than three months prior to the filing of this Statement.

Respectfully submitted,

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RJP/blg

September 10, 2007

# **INFORMATION DISCLOSURE CITATION IN AN APPLICATION**

(Use several sheets if necessary)

Attorney Docket No.:  
**8007-1090**

Application No.:  
**11/529,487**

Applicant:  
**Shinichi MUSHA et al.**

Filing Date:  
**March 28, 2005**

Group Art Unit:  
**1745**

## **U.S. PATENT DOCUMENTS**

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing date (if appropriate)

## **FOREIGN PATENT DOCUMENTS**

Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
	2000-195503	7/14/2000	JAPAN			*	
	2000-251933	9/14/2000	JAPAN			*	

## **OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)**

Notice of Rejection from Japan Patent Office, June 19, 2007.

EXAMINER:

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

\* English language abstract provided for the Examiner's convenience

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